



QC-001-1C

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: David Zuck and Kurtis Macura

Assignee: Quantum Clean

Title: "Steam Cleaning System and Method for Semiconductor Process Equipment"

Serial No.: 10/664,351

Filing Date:

09/16/2003

Examiner: Carrillo, S.

Art Unit:

1746

Docket No.: QC-001-1C

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Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

Sir:

In response to the Final Office Action dated December 20, 2004 (hereafter "OA"),  
please amend the above-identified application as follows:

XO  
OK  
W  
3/21/05  
JG